FORM PTO-1595 (Rev. 6-93)	04-25-2000	SHEET U.S. DEPARTMENT OF COMMERCE Patent and Trademark Office	
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To the Honorable Commissioner of F	101334109	.ached original documents or copy thereof.	
Name of conveying party(ies):		e and address of receiving party(ies)	
Masataka SHINOGI,	Name	: Seiko Instruments R&D Center Inc.	
Yutaka SAINOH and Kenji KATO	Intern	al Address:	
Additional name(s) of conveying party(ies) attached? Ye		al Address:	
3. Nature of conveyeince:		M C	
Assignment □ Mer	ger Stree	t Address: 8, Nakase 1-chome,	
☐ Security Agreement ☐ Cha	nge of Name	Mihama-ku, Chiba-shi	
Other	City:_	Chiba State: Japan ZIP:	
Execution Date: Mar. 13, 2000	Additio	nal name(s) & address(es) attached? ☐ Yes 🗷 No	
4. Application number(s) or patent number(s):		Ard: 3.21.00	
If this document is being filed together with a new application, the execution date of the application is:			
A. Patent Application No.(s) 08/844,15	D. P.	atent No.(s)	
Additional numbers attached? ☐ Yes No			
Name and address of party to whom correspondencement should be mailed:	ondence 6. Total	number of applications and patents involved:	
Name: Bruce D. Adams, Esquir	Te 7. Total	fee (37 CFR 3.41)\$\\\\40.00	
Internal Address:	1	nclosed	
	———	uthorized to be charged to deposit account	
		ny deficiency in enclosed fee	
Street Address: _Adams & Wilks	8. Depo	sit account number:	
50 Broadway-31st	77.3	-0268	
City: New York State: NY Z	70004		
City: State: N1 21	P:_10004 (Affact	n duplicate copy of this page if paying by deposit account)	
24/2000 TTON11 00000459 08844151 DO NOT USE THIS SPACE			
9. Statement and signature.			
To the best of my knowledge and belief, the foregoing information is tyle and correct and any attached copy is a true copy of			
the original document.			
Name of Person Signing Signature MAR. 17, 2000 Date			
Total number of pages including cover sheet, attachments, and document:			

ASSIGNMENT

WHEREAS, we, Masataka Shinogi, Yutaka Saitoh and Kenji Kato, residing at 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan have invented new and useful improvements in METHOD OF MANUFACTURING SEMICONDUCTOR ACCELERATION SENSOR

for which we have prepared an application for Letters Patent of the United States of America;

FND WHEREAS, Seiko Instruments R&D Center Inc., located and doing business at 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan, is desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor;

N()W, THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.00) and other good and valuable consideration to us in hand paid, the receipt of which is hereby acknowledged, we have assigned, sold and transferred and by these presents do hereby assign, sell and transfer unto the said Seiko Instruments R&D Center Inc. for the territory of the United States of America, our entire right, title and interest in and to the said invention, and in and to the said application, prepared and executed by us on <u>June 2, 1997</u>, filed <u>April 18</u>, $19\underline{97}$, Serial No.98/844, 151, preparatory to obtaining Letters Patent thereon and in and to any and all divisions, reissues and continuations thereof, and in and to any Letters Patent that may be granted thereon; said invention, application and Letters Patent to be held and enjoyed by the said Seiko Instruments R&D Center Inc., its legal representatives and assigns, as fully and entirely as the same would have been held by us had this assignment, sale and transfer not been made.

> PATENT REEL: 010716 FRAME: 0757

AND, we hereby covenant and agree that we will at any time upon the request and at the expense of said assignee execute and deliver any and all papers and do all lawful acts that may be necessary or desirable to perfect the title to said invention and to obtain Letters Patent therefor, and we hereby authorize and request the Honorable Commissioner of Patents and Trademarks to issue the said Letters Patent to the said Seiko Instruments R&D Center Inc. in accordance with this assignment.

Executed this <u>13th</u>	day of <u>March</u> , XXX at
Witness: Akiko Hamabata	Masataka Shinogi
	Yutaka Saitoh (L.S.)
	<u>Renje Rato</u> (L.S.) Kenji Kato
	(L.S.)
	(L.S.)
	(L.S.)
	(L.S.)

RECORDED: 03/17/2000

PATENT REEL: 010716 FRAME: 0758